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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/016,035	12/12/2001	Anthony D. Kurtz	Kulite-66	4041	
28581	7590 12/05/2003		EXAMINER		
	ORRIS LLP	ни, ѕно	HU, SHOUXIANG		
100 COLLEGE ROAD WEST, SUITE 100 PRINCETON, NJ 08540-6604		. 100	ART UNIT	PAPER NUMBER	
			2811		

DATE MAILED: 12/05/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

					RE			
4		Appli	cation No.	Applicant(s)	19			
			16,035	KURTZ ET AL.	KURTZ ET AL.			
<u>ે</u>	Office Action Summary	Exam	iner	Art Unit				
			xiang Hu	2811				
Period fo	The MAILING DATE of this commun or Reply	ication appears or	n the cover sheet with the	correspondence add	ress			
THE - Exte after - If the - If NC - Failt - Any	ORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNI nsions of time may be available under the provisions SIX (6) MONTHS from the mailing date of this common period for reply specified above is less than thirty (3) period for reply is specified above, the maximum stature to reply within the set or extended period for reply reply received by the Office later than three months a ed patent term adjustment. See 37 CFR 1.704(b).	CATION. of 37 CFR 1.136(a). In a unication. 0) days, a reply within the tutory period will apply a will, by statute, cause th	no event, however, may a reply be e statutory minimum of thirty (30) d and will expire SIX (6) MONTHS fro e application to become ABANDOI	timely filed lays will be considered timely. om the mailing date of this com	nmunication.			
1)⊠	Responsive to communication(s) file	d on <u>22 Se<i>ptemb</i></u>	<u>oer 2003</u> .					
2a)⊠	This action is <b>FINAL</b> . 2	b) ☐ This action	is non-final.					
3)	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposit	ion of Claims							
5)□ 6)⊠ 7)□	Claim(s) <u>1-6 and 8-20</u> is/are pending 4a) Of the above claim(s) is/a Claim(s) is/are allowed. Claim(s) <u>1-6, 8-20</u> is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restrict	re withdrawn fron	n consideration.					
• —-	ion Papers							
10)	The specification is objected to by the The drawing(s) filed on is/are: Applicant may not request that any objected to graph the oath or declaration is objected to	a) accepted of acc	g(s) be held in abeyance. Sequired if the drawing(s) is	See 37 CFR 1.85(a). objected to. See 37 CFF				
•	under 35 U.S.C. §§ 119 and 120							
12)	Acknowledgment is made of a claim  All b) Some * c) None of:  1. Certified copies of the priority  2. Certified copies of the priority  3. Copies of the certified copies application from the Internation See the attached detailed Office action Acknowledgment is made of a claim from the ince a specific reference was included  7 CFR 1.78.  A) The translation of the foreign lare Acknowledgment is made of a claim from the first sense included in the first sense.	documents have documents have of the priority doc nal Bureau (PCT n for a list of the or domestic priorid in the first sentenguage provisional or domestic priorid	been received. been received in Application been received in Application been received in Application cuments have been received. Rule 17.2(a)). certified copies not receive under 35 U.S.C. § 119 ence of the specification all application has been receive under 35 U.S.C. §§ 129	ation No ived in this National S ved. 9(e) (to a provisional a or in an Application D eceived. 20 and/or 121 since a	application) Data Sheet.			
2) Notice	nt(s) ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (F rmation Disclosure Statement(s) (PTO-1449) P	· ·		ary (PTO-413) Paper No(s) Il Patent Application (PTO-				

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#### **DETAILED ACTION**

# **Drawings**

1. New corrected drawings are required in this application as the proposed drawing corrections filed on September 22, 2203, has been approved. Applicant is advised to employ the services of a competent patent draftsperson outside the Office, as the U.S. Patent and Trademark Office no longer prepares new drawings. The corrected drawings are required in reply to the Office action to avoid abandonment of the application. The requirement for corrected drawings will not be held in abeyance.

# Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-6 and 8-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kurtz'771 (US 5,955,771) in view of Kurtz'277 (US 4,222,277) and/or Kurtz'942 (US 4,025,942).

Kurtz'771 discloses an absolute pressure transducer (see Fig. 7C) and a differential pressure transducer (see Fig. 9), each comprising a piezoresistive pressure sensor (also see Fig. 2) and a glass cover member (72), wherein each of the transducers is formed with a method and material set substantially the same as that of

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the first and second sensors in the instant invention, as admitted in the instant specification (see sections [002] to [004]), and the glass cover member in the differential pressure transducer has a port aperture (84).

Kurtz'771 does not expressly disclose that the two sensors can be formed together through a common wafer process, that the sensors can have a substantially same diaphragm thickness and can have two different active areas. However, one of ordinary skill in the art would readily recognize that such two types of sensors can be desirably integrated in a single transducer for measuring both absolute and differential pressures at the same time (as evidenced in the prior art such as Knecht et al., US 4,790,192; see the abstract, and col. 2, lines 32-34); and that two sensor diaphragms capable of respectively sensing absolute and differential pressures can be cost/effectively formed from a same wafer through a common wafer process, as evidenced in Kurtz'277 (see Figs. 4 and 5 for the diaphragm (capable of sensing absolute pressure) under the pizeoresistive element 16, the diaphragm (capable of sensing differential pressure) under the pizeoresistive element 18, the cover member 30, and the port aperture 31), wherein the two diaphragms have a substantially same thickness. And, one of ordinary skill in the art would also readily recognize that each of individual pressure sensors can have its own optimized active area, which can be either larger or small compared to other's, but suitable to the pressure to be sensed by it, as evidenced in Kurtz'942 (see col. 1, lines 33-52), which manifests the art-known relationship between the pressure P and the active area (or radius a) for a diaphragm with a desired/optimized design point of strain).

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Therefore, it would be have been obvious to one of ordinary skill in the art at the time the inventions was made to incorporate the common wafer process of Kurtz'277 into the transducer of Kurtz'771 with the integrated two sensors having different active areas, as taught in Kurtz'942, so that a transducer capable of sensing both absolute and differential pressures with optimized performance for each of the two sensors therein would be obtained in a cost/effective way. And, in such a collectively taught transducer, the two sensors would be naturally matched in regard to thermal properties, as it would be formed in a method substantially the same as that in the instant invention.

Regarding claim 2, one of ordinary skill in the art would readily recognize that the two sensors can be diced into two separated pieces so as to best fit the desired device layout. In addition, it is noted that it has been held that constructing a formerly integral structure in various elements involves only routine skill in the art. See *Nerwin v. Erlichman*, 168 USPQ 177, 179.

### Response to Arguments

3. Applicant's arguments filed on September 22, 2003, have been fully considered but they are not persuasive.

Applicant's main arguments include: Kurtz'942 does not teach or suggest the desirability of providing a transducer having two sensors with different active areas. In response to applicant's arguments against the references individually, it is noted that one cannot show nonobviousness by attacking references individually where the rejections are based on combinations of references. See *In re Keller*, 642 F.2d 413,

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208 USPQ 871 (CCPA 1981); In re Merck & Co., 800 F.2d 1091, 231 USPQ 375 (Fed. Cir. 1986). In this case, Kurtz'771 expressly teaches the individual structures of the absolute pressure transducer and the differential pressure transducer, each comprising a piezoresistive pressure sensor and a glass cover member. And, as evidenced in Kurtz'277, along with Knecht et al., one of ordinary skill in the art would readily recognize that such two types of sensors can be readily and desirably integrated in a single transducer for measuring both absolute and differential pressures at the same time. Kurtz'942 (see col. 1, lines 33-52) expressly shows the art-known correlation between the pressure P and the active area (or radius a) for the diaphragm in the individual pressure sensor. Thus, each of the active areas of integrated pressure sensors is an art-recognized parameter of importance subject to routine experimentation and optimization. Therefore, it would be well within the ordinary skill in the art to make an integrated transducer, such as the one collectively taught by Kurtz'771 and Kurtz'277, with the integrated two sensors therein having different active areas according to their intended individual design points for the pressures or strains, per the teachings of Kurtz'942, in order to form a transducer capable of sensing both absolute and differential pressures with optimized performance for each of the two sensors therein.

#### Conclusion

4. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

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A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not

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mailed until after the end of the THREE-MONTH shortened statutory period, then the

shortened statutory period will expire on the date the advisory action is mailed, and any

extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

the advisory action. In no event, however, will the statutory period for reply expire later

than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shouxiang Hu whose telephone number is (703) 306-5729. The examiner can normally be reached on Monday through Thursday, 7:30 AM

to 6:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eddie C. Lee can be reached on (703) 308-1690. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9318.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

SH

December 3, 2003

SHOUXIANG HU BIMARY EXAMINER

Shouvenegfle